

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date October 24, 2007

In re the Application of

Yasuhiro OMURA et al.

Application No.: 10/525,372

Filed: February 23, 2005

For: PROJECTION OPTICAL SYSTEM AND METHOD FOR PHOTOLITHOGRAPHY AND
EXPOSURE APPARATUS AND METHOD USING SAME

Group Art Unit: 2873

Examiner: M. HASAN

Docket No.: 122800

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired September 28, 2007, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 198403 in the amount of \$120 in payment for:

<u>X</u>	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$460.00)
<u> </u>	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461